



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hisashi Ohtani et al    Art Unit : 1765  
Serial No.: 08/690,747                      Examiner : Robert Kunemund  
Filed: August 1, 1996  
Title : METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

BOX RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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TC 1700

AMENDMENT ACCOMPANYING A

REQUEST FOR CONTINUED EXAMINATION UNDER 37 CFR 1.114

By the timely filing of this submission and fee set forth in 37 CFR 1.17(e), the period for response which has been extended for two months by filing a request for extension of and fee payment filed concurrently herewith, please withdraw the finality of any Office action and amend the above-captioned application before examination as follows:

In the Claims:

Please cancel claims 1-3, 5-8, 10-14, 16-20, 22-24, and 26-36 without prejudice or disclaimer. Please add the following new claims 49-96:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit

February 21, 2001

Signature

Veronica Whalen

Typed or Printed Name of Person Signing Certificate

Veronica Whalen